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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of : **Confirmati n No. 4423**  
Tomohiro OKUMURA et al. : Docket No. 2001\_1089A  
Serial No. 09/918,823 : Group Art Unit 2821  
Filed August 1, 2001 : Examiner T. Phan

PLASMA PROCESSING METHOD  
AND APPARATUS THEREOF

**PETITION FOR EXTENSION OF TIME**

Assistant Commissioner for Patents,  
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

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Sir:

Petition hereby is made for a three month extension of time to respond to the communication of August 28, 2002.

The fee of \$930.00 is

- ☒ submitted herewith.  
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.  
☐ Small entity status of this application is established by a Small Entity Status Assertion which  
☐ is enclosed.  
☐ has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By

W. Douglas Hahm  
Registration No.44,142  
Attorney for Applicants

WDH/lgs  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
February 28, 2003

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